IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Christoph BRABEC et al.
Application No ·	NEW APPLICATION

Filed: S

September 23, 2003

For:

X-RAY DETECTOR INCLUDING A SCINTILLATOR WITH A

PHOTOSENSOR COATING, AND A PRODUCTION PROCESS

INFORMATION DISCLOSURE STATEMENT (SUBMISSION CONCURRENT WITH THE FILING OF A NEW PATENT APPLICATION)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 September 23, 2003

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on PTO-1449, attached hereto.

II. COPIES

M	Submitted herewith is a legible copy of (i) each U.S. and foreign patent; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed.
	Because the present application was/is being filed after June 30, 2003, no copies of

Ш	Because the present application was/is being filed after June 30, 2003, no copies of
	the U.S. patents or U.S. patent application publications which are listed on the
	attached Form 1449 are enclosed pursuant to the waiver of 37 C.F.R. § 1.98(a)(2)(i).
	Any foreign patent documents or non-patent literature listed on the attached Form
	1449 are enclosed herewith.

Ш.	CONCISE EXPLANATION OF THE RELEVANCE (check at least one box)		
	a.	\boxtimes	DOCUMENTS IN THE ENGLISH LANGUAGE
			The attached patents, publications, or other information in the English language do not require a statement of relevancy.
	b.		DOCUMENTS NOT IN THE ENGLISH LANGUAGE
			A concise explanation of the relevance of all patents, publications, or other information listed that is not in the English language is as follows:
	c.		OTHER

FEES

This Information Disclosure Statement is being filed concurrently with the filing of a new patent application; therefore, no fee is required.

If The Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule and charge the appropriate fee to Deposit Account No. 08-0750.

New U.S. Application Docket No. 32860-000625/US

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Respectfully submitted,

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Reston, Virginia 20195

DJD:bmd

P.O. Box 8910 (703) 668-8000

Enclosures: Form PTO-1449(s) Documents Fee

FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

Sheet 1 of 2

ATTORNEY DOCKET NO.	SERIAL NO.	
32860-000625/US	Unknown	
APPLICANT		
Christoph BRABEC et al.		
FILING DATE	GROUP	

Unknown

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
		6,133,574	10/17/2000	Blendinger	250/370.11	

September 23, 2003

	Examiner's	Document			Class/	Translatio	
Desig.	Initials	Number	Date	Country	Subclass	Yes	No
		99/09603	2/25/1999	wo			
		99/09603 - Corrected Version	2/25/1999	wo-			
		02016364.8	7/25/2002	Europe			
		99/39335	8/05/1999	wo			

Ref. Desig.	Examiner's Initials	
		Tetsuhiko TAKAHASHI, Haruo ITOH, Toshikazu SHIMADA, and Hiroshi TAKEUCHI, "Design of Integrated Radiation Detectors with a – Si Photodiodes on Ceramic Scinillators for use in X-Ray Computed Tomography", IEEE Transactions on Nuclear Science; Vol. 37, No. 3, June 9, 1990, p. 1478-1482

Examiner:	Date Considered:

NR.	Dokument	Bemerkungen
	aus Recherchenbericht	
1	DE 197 28 237 A1 = US 6,133,574 A1	
2	WO 99/09603 A1	
3	T. Takahashi et al., "Design of Integrated Radiation Detectors with a-Si Photo- diodes on Ceramic Scintillators for use in X-ray Computed Tomography", IEEE Transactions on Nuclear Science, Vol. 37, No. 3, June 1990, p. 1478-1482	
4	EP 12 91 676 A2	
	in der Beschreibungseinleitung gen	annt
5	wie 2.	
	weiterer Stand der Technik	
6	WO 99/39395 A1	
ļ		
一	im engen Zusammenhang stehend	le US-Anmeldungen
Unte	erschrift des Patentingenieurs	Datum 14.08.2003

IDNR: 2452 / V: 99-1.00 / B:Val